

# Carbon MEMS Accelerometer

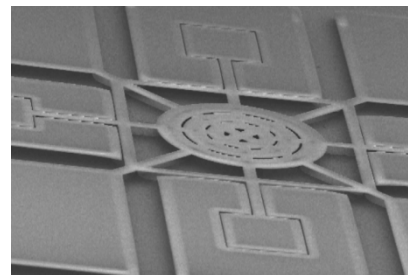
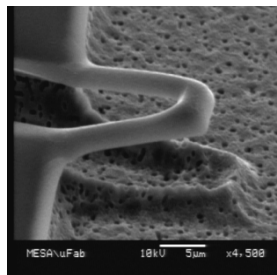
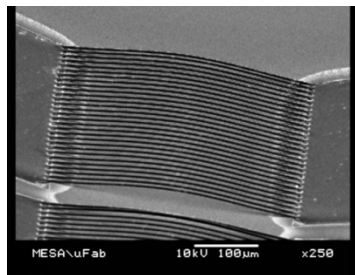
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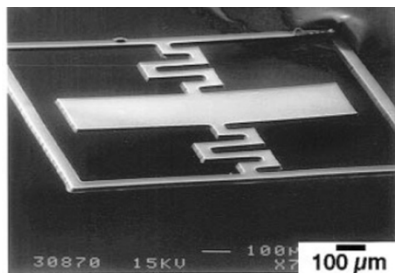
# Project Goals

- Intent is to design a MEMS accelerometer that is hyper-sensitive over a dynamic range from micro-G to hundreds of G's
- The design will utilize photo-patternable material with blended nano-materials
- The blend undergoes pyrolysis, resulting in a carbon-carbon composite with pyrolytic carbon comprising the bulk of the material

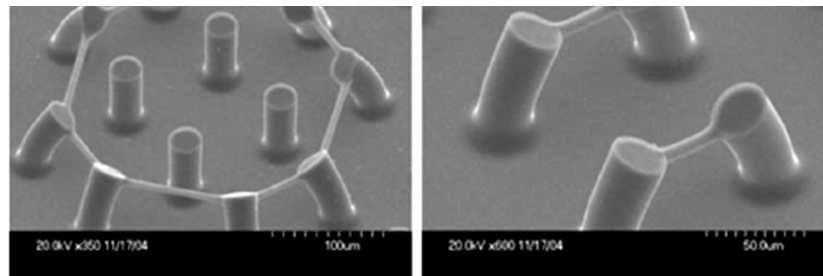


# Background

- The pyrolysis of photo-patternable materials and the basic properties of pyrolytic carbon have been described by G. Whitesides [1]
- M. Madou [2] and R. McCreery [3] have developed carbon on carbon approaches to develop carbon MEMS
- Pyrolytic carbon structures have survived 150 G's



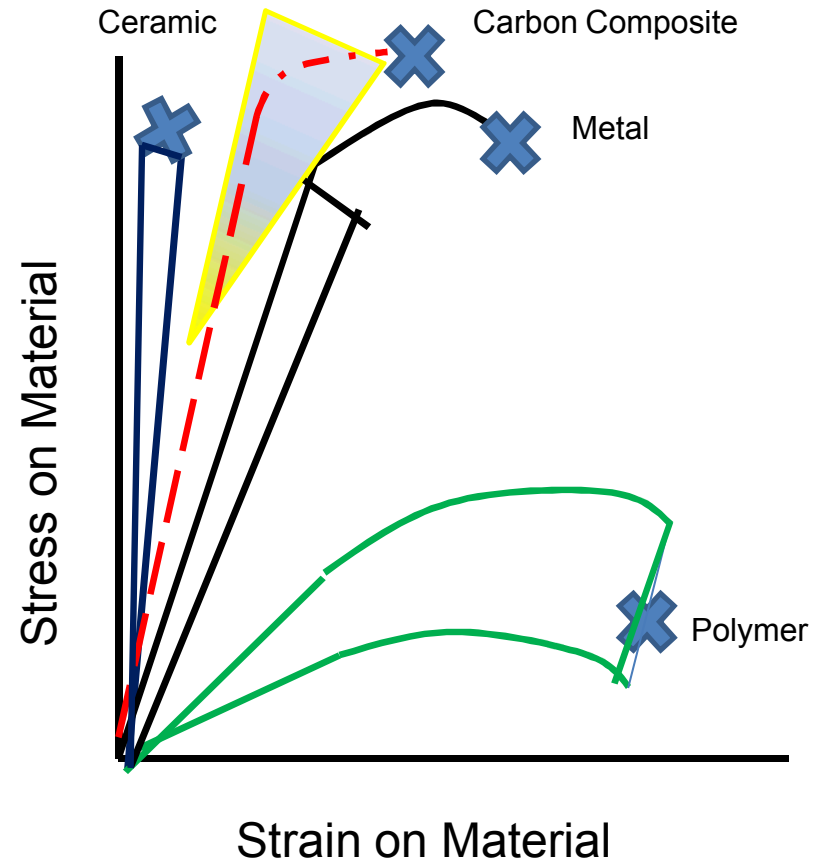
Free-Standing Pyrolytic Carbon Structure by G. Whitesides [1]

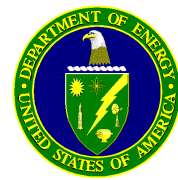


Suspended C-MEMS Structures by M. Madou [2]

# Tuning Pyrolytic Carbon

- Pyrolytic carbon alone does not have the electromechanical properties desired
- By blending nano-materials such as CNTs into the photoresist before pyrolysis, the properties of the carbon can be tuned to better suit the design
- First attempt uses MWCNTs 40-70 nm in diameter and 0.5 – 5.0  $\mu\text{m}$  in length





# Outline of Work

## Composite Characterization

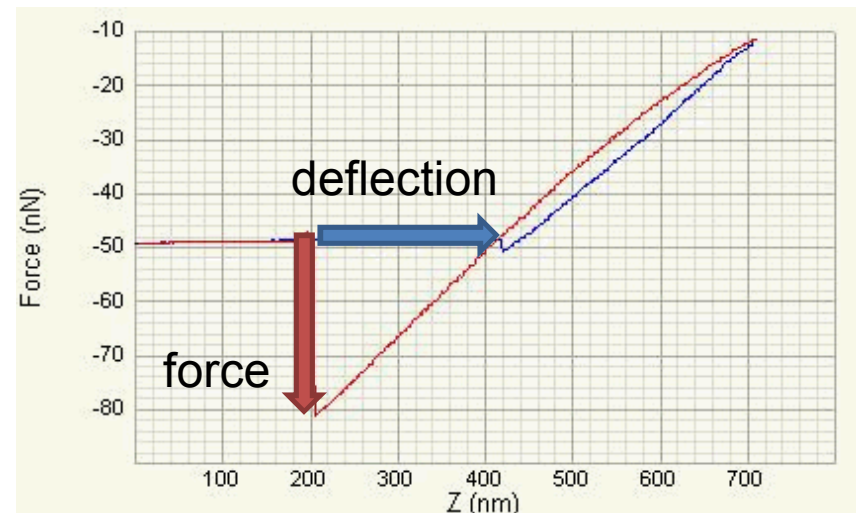
- Fabricate test devices and preliminary designs from a variety of carbon-carbon composites
- Collect physical data
- Calculate basic material properties
- Use COMSOL to validate the calculations

## Device Design

- Correlate the COMSOL models with physical data
- Use the COMSOL models to drive design optimization with less need for fabrication
- Use COMSOL to explore and screen new designs pre-fabrication

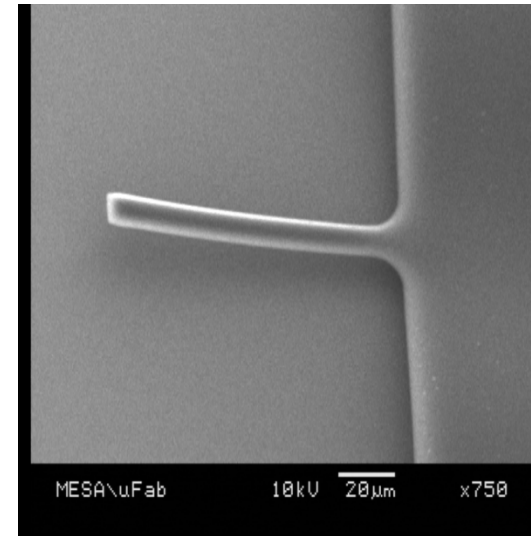
# AFM Measurements

- Atomic Force Microscopy (AFM) is used to explore the basic mechanical functioning of the composites
- AFM provides a basic look at device deflection versus applied force



# Young's Modulus

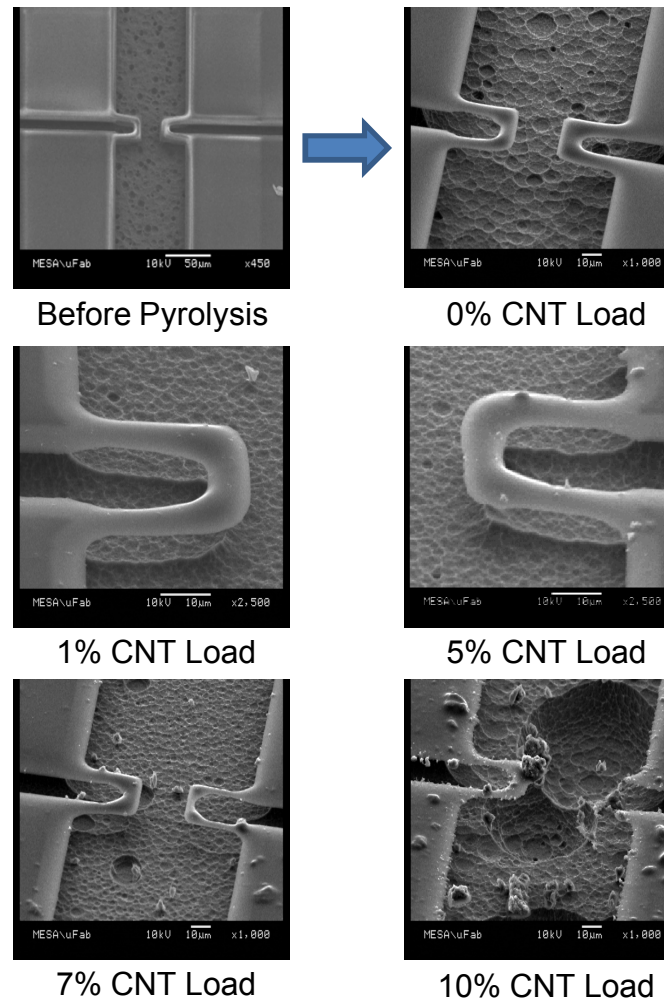
- By examining the relationship between force versus deflection for simple cantilever devices, a value for Young's modulus can be extracted
- This requires the assumption that the measurements are in the linear elastic range



$$k = \frac{F}{\delta} \quad E = \frac{4FL^3}{bh^3\delta}$$

# Early Results

- First composite devices show promising fabrication results
- The geometries reduce ~80% during pyrolysis
- CNT loading over 5% results in damage to structures
- Better dispersion techniques will help

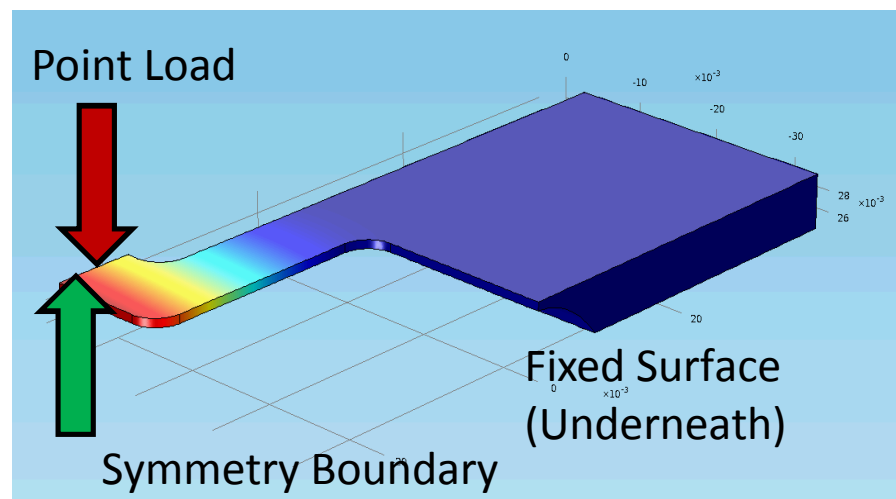


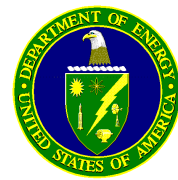


# Early Results

- Values for Young's modulus are lower than expected – problem may lie in initial AFM measurements
- COMSOL model exhibits deflection within 5% of what is expected for the given Young's modulus

CNT Loading	Young's Modulus (GPa)
0%	2.22
1%	2.16
5%	3.01
7%	1.94
10%	2.16



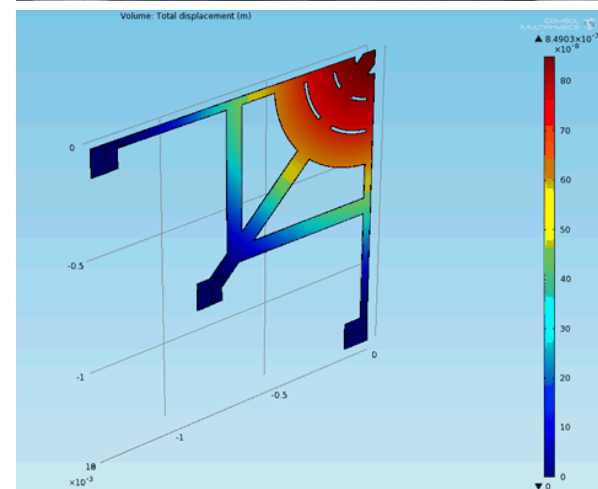
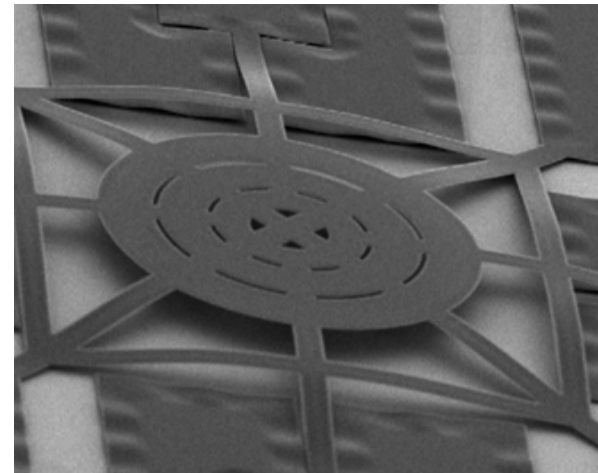


# Recent Results

- More recent AFM measurements yielded a Young's modulus of 52.3 GPa for unloaded pyrolytic carbon
- This is much higher than the 2.22 GPa calculated previously
- This value is higher than expected – previous literature cites a value of ~15 GPa [1]
- In comparison, aluminum has a Young's modulus of ~69 GPa
- More measurements are needed to establish consistency

# Recent Results

- Recent AFM data also included measurements for a diaphragm device
- The COMSOL model of the device did not behave as expected
- The model deflected 849nm – 238nm was expected
- Internal stresses may be playing a role in the physical device





# The Value of COMSOL Modeling

- Comparing a physical device to its COMSOL model yields valuable insight regardless of the outcome being favorable or not
- Good correlation gives confidence that the model can be used to make meaningful predictions
- Poor correlation leads to troubleshooting
  - There is an error in the model
  - Fabrication artifacts are not being taken into account
  - There is a misunderstanding of the physical structures or materials



# Going Forward

## Composite Characterization

- Establish consistency in the AFM measurements
  - More data points
  - Use of a “test wafer” to ensure that the AFM tip is consistent from one set of measurements to the next
- Attempt to create larger devices that can be used in macro-scale testing

## Device Design

- Troubleshoot differences between the physical data and the COMSOL models
- Refine device fabrication methods to eliminate unwanted physical artifacts
- Eventually use COMSOL for design optimization and for evaluating and comparing different designs



# Acknowledgements and References

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2. M. Madou, et. al. Carbon 2006, 44(13), 2602-2607
3. R. McCreery, et. al. Journal of The Electrochemical Society, 147, (1) 277-282